

<b>Notice of References Cited</b>	Application/Control No. 10/826,090	Applicant(s)/Patent Under Reexamination CHEN, SHI-SHIEN	
	Examiner Samuel G. Neway	Art Unit 2626	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,455,577	10-1995	Slivka et al.	341/51
	B	US-			
	C	US-			
	D	US-			
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**FOREIGN PATENT DOCUMENTS**

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